

(19) World Intellectual Property
Organization
International Bureau



(43) International Publication Date
17 November 2005 (17.11.2005)

PCT

(10) International Publication Number
WO 2005/108650 A1

(51) International Patent Classification⁷: **C25D 5/00**

(21) International Application Number:
PCT/US2005/013211

(22) International Filing Date: 20 April 2005 (20.04.2005)

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data:
10/833,194 27 April 2004 (27.04.2004) US

(71) Applicant (for all designated States except US): **ADVANCED TECHNOLOGY MATERIALS, INC**
[US/US]; 7 Commerce Drive, Danbury, CT 06810-4169 (US).

(72) Inventors; and

(75) Inventors/Applicants (for US only): **HAN, Jianwen**
[CA/US]; 3002 Hancock Drive, Danbury, CT 06810 (US). **KING, Mackenzie** [CA/US]; 158 Luther Drive, Southbury, CT 06488 (US).

(74) Agent: **HULTQUIST, Steven, J.**; Intellectual Property/Technology Law, P.O. Box 14329, Research Triangle Park, NC 27709 (US).

(81) Designated States (unless otherwise indicated, for every kind of national protection available): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KM, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SM, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.

(84) Designated States (unless otherwise indicated, for every kind of regional protection available): ARIPO (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IS, IT, LT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Published:

— with international search report

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: METHODS AND APPARATUS FOR DETERMINING ORGANIC COMPONENT CONCENTRATIONS IN AN ELECTROLYTIC SOLUTION

(57) Abstract: The present invention relates to a method and apparatus for determining organic additive concentrations in a sample electrolytic solution, preferably a copper electroplating solution, by measuring the double layer capacitance of a measuring electrode in such sample solution. Specifically, the present invention utilizes the correlation between double layer capacitance and the organic additive concentration for concentration mapping, based on the double layer capacitance measured for the sample electrolytic solution.



WO 2005/108650 A1

METHODS AND APPARATUS FOR DETERMINING ORGANIC COMPONENT CONCENTRATIONS IN AN ELECTROLYTIC SOLUTION

BACKGROUND OF THE INVENTION

Field of the Invention

[0001] The present invention relates to methods and apparatuses for determining organic component concentrations in an electrolytic solution, and more specifically to determination of organic component concentrations in a copper electroplating solution.

Description of the Related Art

[0002] In electrochemical deposition (ECD) process, the rigorous control of the relative proportions of respective inorganic and organic ingredients in the ECD bath is critical to the achievement of satisfactory results in the rate of metal film formation and the quality of the film so formed. During the use of the plating bath solution, the plating process may be affected by depletion of inorganic components and organic additives as well as by organic byproduct formation. The ECD bath chemistry therefore must be maintained by periodic replacement of a part or the entire ECD bath. It is therefore important to continuously or periodically monitor the concentrations of inorganic and/or organic components in the ECD bath, and responsively add respective components to the bath to maintain the composition of the bath in an effective state for the electrochemical deposition operation.

[0003] It is therefore one object of the present invention to provide an improved method for measuring concentrations of one or more organic components in an ECD bath.

[0004] Other objects and advantages will be more fully apparent from the ensuing disclosure and appended claims.

SUMMARY OF THE INVENTION

[0005] The present invention in one aspect relates to a method for determining concentration of an organic component in a sample electrolytic solution. Such method comprises the steps of:

- (a) applying a potential step to the sample electrolytic solution by using at least a working electrode and a reference electrode;
- (b) measuring double layer capacitance of the working electrode in the sample electrolytic solution under the applied potential step; and
- (c) determining the concentration of the organic component in the sample electrolytic solution, based on the double layer capacitance measured in step (b).

[0006] Another aspect of the present invention relates to an apparatus for measuring concentration of an organic component in a sample electrolytic solution, comprising:

- (a) a measuring chamber containing a working electrode and a reference electrode, for receiving at least a portion of the sample electrolytic solution;
- (b) an electrical source for applying a potential step to the sample electrolytic solution through the working and reference electrodes;
- (c) means for measuring double layer capacitance of the working electrode in said sample electrolytic solution under the applied potential step; and
- (d) computational means for determining the concentration of the organic component in said sample electrolytic solution, based on the double layer capacitance measured for the working electrode in the sample electrolytic solution.

[0007] Other aspects, features and embodiments of the present invention will be more fully apparent from the ensuing disclosure and appended claims.

BRIEF DESCRIPTION OF THE DRAWINGS

[0008] Figure 1 shows the current response curves measured for four different electrolytic solutions over time under an initial potential step of about -0.208V.

DETAILED DESCRIPTION OF THE INVENTION, AND PREFERRED EMBODIMENTS THEREOF

[0009] The boundary between a measuring electrode and an electrolytic solution is called an

interface. The electrolytic solution is a first phase in which charge is carried by the movement of ions, and the measuring electrode is a second phase in which charge is carried by the movements of electrons.

[0010] Two types of processes occur at the electrode-solution interface: (1) the faradaic process involves actual electron transfers between the measuring electrode and the electrolytic solution; and (2) the non-faradaic process involves adsorption and desorption of organic species onto and from the electrode surface where no charge actually cross the interface.

[0011] During non-faradaic process, although no charge actually cross the interface, external transient currents are present when the electrical potential, electrode surface area, or the composition of the electrolytic solution changes. These transient currents flow to charge or discharge the electrode-solution interfacial region, which is generally referred to as an *electrical double layer*.

[0012] The capacitance of such electrical double layer (C_d) is a function of the applied electrical potential (E), the composition and concentration of the electrolytic solution, and the active electrode surface area. When the applied electrical potential and the active electrode surface area are constant, the double layer capacitance is directly correlative to the composition and concentration of the electrolytic solution.

[0013] Therefore, the present invention in one aspect provides a method for measuring the organic additive (i.e., suppressors, accelerators, and levelers) concentrations in a metal electroplating solution, more preferably a copper electroplating solution, based on the double layer capacitance of a working electrode that is immersed in such metal electroplating solution.

[0014] Under a given initial electrical potential or potential step (E), the metal electroplating solution demonstrates a current response that is characterized by an initial current peak or maximum current (I_{max}) at initial time t_0 and an exponentially decaying current (I) at subsequent time t , which are determined by:

$$I_{max} = \frac{E}{R_s}; \quad (I)$$

$$I = I_{\max} \times e^{\left(-\frac{t}{R_s C_d}\right)} \quad (\text{II})$$

where R_s is the electrical resistance of the electrolytic solution, and e is the base for natural exponential.

[0015] When $t = R_s C_d$, the current I has decreased to about 37% of the initial current peak, as follows:

$$I = I_{\max} \times e^{(-1)} = 0.368 \times I_{\max} \quad (\text{III})$$

[0016] The value of $R_s C_d$ is usually referred to as the time constant t_c , which is characteristic to the given electrode-solution interface.

[0017] From equations (I)-(III), one can express the double layer capacitance C_d as:

$$C_d = \frac{t_c \times I_{\max}}{E} \quad (\text{IV})$$

[0018] Therefore, by measuring the current peak $I_{\max}$, the time constant t_c required for the current to decrease to about 37% of the current peak $I_{\max}$, and the initial potential step E , the double layer capacitance C_d of the measuring electrode in the sample electroplating solution can be determined quantitatively.

[0019] The current response of an electrolytic solution can be monitored by using one or more measuring devices. For example, an ammeter can be used to directly measuring the current flow through the sample electrolytic solution over time; alternatively, a combination of one or more potentiometers and one or more ohmmeters can be used to measuring the real-time potential and electrical resistance of the sample electrolytic solution, from which the current flow can be calculated.

[0020] Preferably, one or more calibration solutions are provided for constructing a correlative data set, which empirically correlates the double layer capacitance with the concentration of an organic component of interest. Specifically, each calibration solution so provided is compositionally identical to the sample electroplating solution but for the concentration of the

organic component of interest, and each calibration solution preferably contains said organic component of interest at a unique, known concentration. The double layer capacitance of each calibration solution is measured according to the method described hereinabove and used in conjunction with the respective known concentration of the organic component of interest in each calibration solution to form the correlative data set.

[0021] Such correlative data set can then be used for direct mapping of the concentration of the organic component of interest in the sample electroplating solution, based on the double layer capacitance measured for such sample electroplating solution.

[0022] Preferably, the present invention employs a computer-based quantitative analyzer, which may comprise a computer, central processor unit (CPU), microprocessor, integrated circuitry, operated and arranged to collect the current response data for determining the double layer capacitance of the sample solution and according to the method described hereinabove and for mapping the organic component concentration. More preferably, such quantitative analyzer has a correlative data set stored in its memory for direct concentration mapping based on the double layer capacitance measured for the sample solution. Alternatively, such quantitative analyzer comprises a capacitance-concentration correlation protocol for *in situ* construction of such a correlative data set based on current response data collected for various calibration solutions and the respective known organic component concentrations in such calibration solutions. The capacitance-concentration correlation protocol can be embodied in any suitable form, such as software operable in a general-purpose programmable digital computer. Alternatively, the protocol may be hard-wired in circuitry of a microelectronic computational module, embodied as firmware, or available on-line as an operational applet at an Internet site for concentration analysis.

[0023] Usage of double layer capacitance for determining organic component concentrations in the present invention is particularly advantageous for analysis of copper electroplating solutions. First, measurement of the double layer capacitance involves little or no reduction of the copper ions (Cu^{2+}), because such measurement is carried out in a potential range that is lower than that required for Cu^{2+} reduction reaction, which protects the measuring electrode

from being alloyed with the reduced copper and increases the useful life of the electrode. Further, since measurement of the double layer capacitance does not involve copper deposition, the organic additives contained in the sample electrolytic solution are not consumed, and the concentration of such organic additives in the electrolyte solution throughout the measurement cycles remains constant, therefore significantly increasing the reproducibility of the measurement results.

[0024] Figure 1 shows the current response curves of four different electrolytic solutions, which include (1) a first electrolytic solution that contains copper sulfate, sulfuric acid, and chloride and is additive-free, (2) a second electrolytic solution that is compositionally identical to the first electrolytic solution but for containing a suppressor at a concentration of about 2.0 mL/L; (3) a third electrolytic solution that is compositionally identical to the first electrolytic solution but for containing an accelerator at a concentration of about 6.0 mL/L; (4) a fourth electrolytic solution that is compositionally identical to the first electrolytic solution but for containing a leveler at a concentration of about 2.5 mL/L.

[0025] An initial potential step (E) of about -0.208V is applied to each of the above-listed electrolytic solutions, and the current response curves of the electrolytic solutions under such initial potential step are obtained.

[0026] The current peak (I_{max}) and the time constant (t_c) required for the current (I) to drop from the peak value to about 37% of the peak value can be directly read from such current response curves, and from which the double layer capacitance (C_d) can be calculated, according to equation (IV) provided hereinabove.

[0027] Following is a table listing the measurements obtained from the current response curves shown in Figure 1.

		Solution (1)	Solution (2)	Solution (3)	Solution (4)
Potential Step (E)		-0.208V	-0.208V	-0.208V	-0.208V
Current Peak (I_{max})	Ave.	-77.6 nA	-45.1 nA	-58.1 nA	-73.8 nA
	RSD	-0.20%	-1.50%	-0.50%	-0.50%
Time Constant (t_c)		0.065 sec.	0.0749 sec.	0.0586 sec.	0.0684 sec.
Double Layer Capacitance (C_d)		24.2 nF	16.2 nF	16.4 nF	24.3 nF
Capacitance Change Rate		0%	-33%	-32%	0.04%

[0028] Among the three organic additives tested, the suppressor as added into solution (2) has the greatest impact on the double layer capacitance, and the leveler as added into solution (4) has the least impact at the given concentration. Therefore, different organic additives have relatively different impact on the double layer capacitance, which can be used for distinguishing said organic components from one another.

[0029] While the invention has been described herein with reference to specific aspects, features and embodiments, it will be recognized that the invention is not thus limited, but rather extends to and encompasses other variations, modifications and alternative embodiments. Accordingly, the invention is intended to be broadly interpreted and construed to encompass all such other variations, modifications, and alternative embodiments, as being within the scope and spirit of the invention as hereinafter claimed.

THE CLAIMS**What is Claimed is:**

1. A method for determining concentration of an organic component in a sample electrolytic solution, said method comprising the steps of:
 - (a) applying a potential step to the sample electrolytic solution by using at least a working electrode and a reference electrode;
 - (b) measuring double layer capacitance of the working electrode in said sample electrolytic solution under the applied potential step; and
 - (c) determining the concentration of the organic component in said sample electrolytic solution, based on the double layer capacitance measured in step (b).
2. The method of claim 1, wherein the sample electrolytic solution comprises a copper electroplating solution, and wherein the organic component comprises an organic additive selected from the group consisting of suppressors, accelerators, and levelers.
3. The method of claim 1, wherein one or more calibration solutions containing said organic component at unique, known concentrations are provided, wherein the double layer capacitance of the working electrode in each of said calibration solutions under the potential step is measured, which is correlated to the concentration of the organic component in respective calibration solution, and wherein the concentration of the organic component in the sample electrolytic solution is determined based on the double layer capacitance measured for said sample electrolytic solution and the capacitance-concentration correlation obtained by measuring the calibration solutions.
4. The method of claim 3, wherein said one or more calibration solutions are compositionally identical to said sample electrolytic solution but for the organic component concentration.

5. The method of claim 1, wherein the double layer capacitance of the working electrode is measured by monitoring current response of the sample electrolytic solution under the potential step over time.

6. The method of claim 5, wherein the double layer capacitance (C_d) of the working electrode is determined by:

$$C_d = \frac{t_c \times I_{max}}{E}$$

wherein E is the applied potential step, I_{max} is the current peak observed under said applied potential step E , and t_c is a time constant, which is equal to the time required for the current to drop from I_{max} to about $0.368 \times I_{max}$.

7. An apparatus for measuring concentration of an organic component in a sample electrolytic solution, comprising:
- (a) a measuring chamber containing a working electrode and a reference electrode, for receiving at least a portion of said sample electrolytic solution;
 - (b) an electrical source for applying a potential step to the sample electrolytic solution through the working and reference electrodes;
 - (c) means for measuring double layer capacitance of the working electrode in said sample electrolytic solution under the applied potential step; and
 - (d) computational means for determining the concentration of the organic component in said sample electrolytic solution, based on the double layer capacitance measured for the working electrode in the sample electrolytic solution.
8. The apparatus of claim 7, wherein the sample electrolytic solution comprises a copper electroplating solution, and wherein the organic component comprises an organic additive selected from the group consisting of suppressors, accelerators, and levelers.

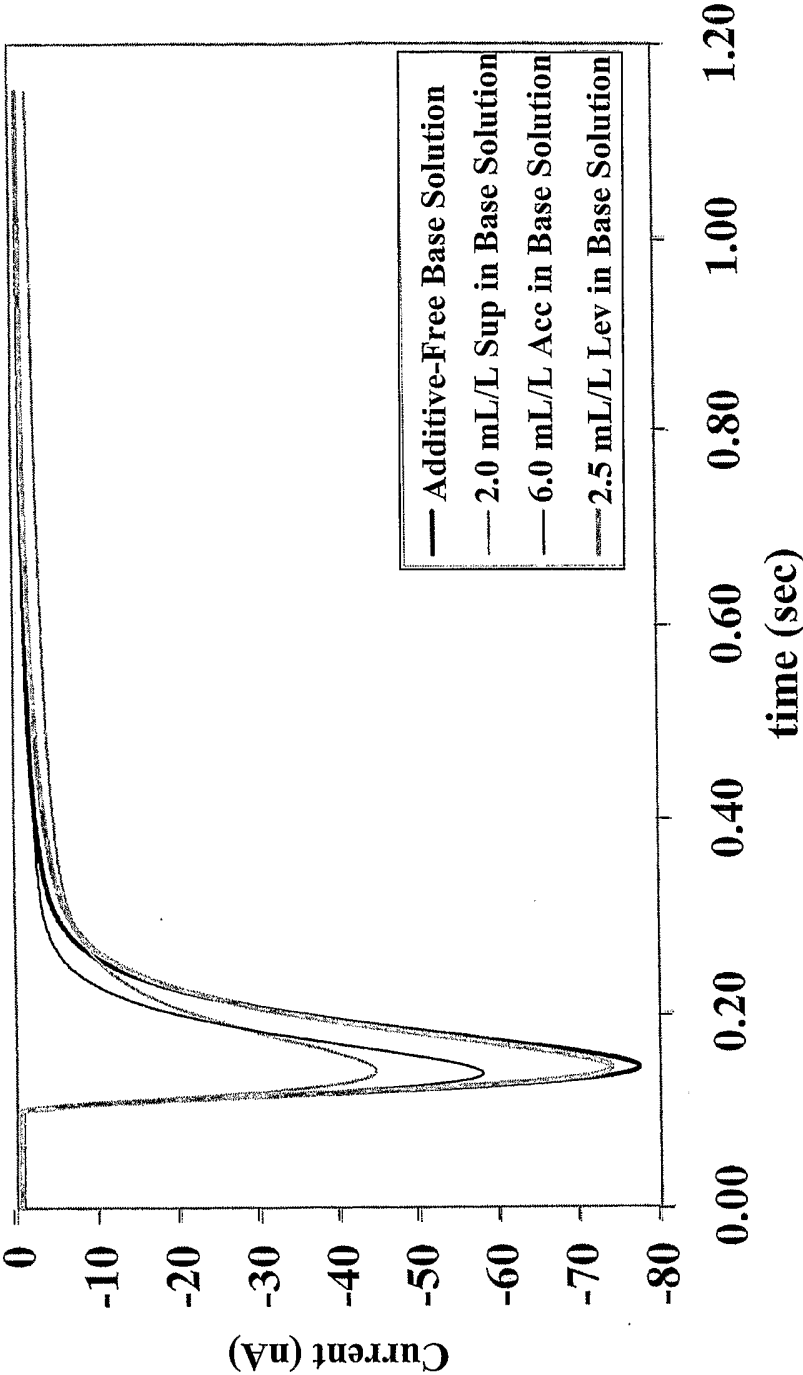
9. The apparatus of claim 7, wherein one or more calibration solutions containing said organic component at unique, known concentrations are sequentially filled into the measuring chamber, wherein the double layer capacitance of the working electrode in each of said calibration solutions under the potential step is measured, which is correlated to the concentration of the organic component in respective calibration solution, and wherein the computational devices determine the concentration of the organic component in the sample electrolytic solution based on the double layer capacitance measured for the sample electrolytic solution and the capacitance-concentration correlation obtained by measuring the calibration solutions.
10. The apparatus of claim 9, wherein said one or more calibration solutions are compositionally identical to said sample electrolytic solution but for the organic component concentration.
11. The apparatus of claim 7, wherein the double layer capacitance of the working electrode is measured by monitoring current response of the sample electrolytic solution under the potential step over time.
12. The apparatus of claim 11, comprising one or more measuring devices selected from the group consisting of potentiometers, ammeters, and ohmmeters.
13. The apparatus of claim 11, wherein the double layer capacitance (C_d) of the working electrode is determined by:

$$C_d = \frac{t_c \times I_{\max}}{E}$$

wherein E is the applied potential step, I_{max} is the current peak observed under said applied potential step E , and t_c is a time constant, which is equal to the time required for the current to drop from I_{max} to about $0.368 \times I_{max}$.

14. The apparatus of claim 7, wherein said computational means comprises one or more devices selected from the group consisting of computer, central processor unit (CPU), microprocessor, and integrated circuitry.
15. The apparatus of claim 14, wherein said computation means maps the concentration of the organic component in said sample electrolytic solution based on the measured double layer capacitance and a correlative data set that empirically correlates double layer capacitance with concentration of the organic component.
16. The apparatus of claim 15, wherein the correlative data set is stored in the memory of the computational means.
17. The apparatus of claim 15, wherein the correlative data set is constructed *in situ* by said computational means according to a capacitance-concentration correlation protocol.

Figure 1



INTERNATIONAL SEARCH REPORT

International application No.

PCT/US05/13211

A. CLASSIFICATION OF SUBJECT MATTER

IPC(7) : C25D 5/00

US CL : 205/81

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

U.S. : 205/81, 82, 84

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)
EAST

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Y	US 4,707,378 A (MCBRIDE et al.) 17 November 1987 (17.11.1987), entire document.	1-17
Y	US 4,812,210 A (BONIVERT et al.) 14 March 1989 (14.03.1989), entire document.	1-17
Y	BARD et al. "Electrochemical methods: Fundamentals and Applications". John Wiley & Sons, Inc. (New York), second edition, pages 15 and 16, entire document.	1-17
Y	US 6,572,753 B2 (CHALYTE et al.) 03 June 2003 (03.06.2003), entire document.	1-17



Further documents are listed in the continuation of Box C.



See patent family annex.

* Special categories of cited documents:

"A"	document defining the general state of the art which is not considered to be of particular relevance	"T"	later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
"B"	earlier application or patent published on or after the international filing date	"X"	document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
"L"	document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)	"Y"	document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
"O"	document referring to an oral disclosure, use, exhibition or other means	"&"	document member of the same patent family
"P"	document published prior to the international filing date but later than the priority date claimed		

Date of the actual completion of the international search

16 June 2005 (16.06.2005)

Date of mailing of the international search report

29 JUN 2005

Name and mailing address of the ISA/US

Mail Stop PCT, Attn: ISA/US
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Facsimile No. (703) 305-3230

Authorized officer

William Dixon

Telephone No. (571) 272-1600